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What is claimed is:

measurement in a two-frequency laser interferometer, which consists of a two-frequency laser interferometer, a 90° phase mixing electronics and a phase angle calculating electronics and performs the steps of mixing a reference signal produced due to an interference of two frequency laser beams and a 90° phase shifted reference signal with a measurement signal for displacement measurement produced due to two frequency laser beams reflected on fixed and moving mirrors, filtering high frequency terms to produce output signals and obtaining a phase angle for displacement measurement, the phase angle measuring method comprising the steps of:

obtaining output signals output from the 90° phase mixing electronics, and ellipse parameters such as amplitudes, offsets and a phase difference included in the output signals; and

applying the same to the following Equation to calculate the phase angle,

$$\theta = \tan^{-1}[\cos \theta / [\sin \theta + (b/a) / (I_x - I_{x0}) / (I_y - I_{y0})]]$$

2. A phase angle measuring method for displacement measurement in a two-frequency laser interferometer, which consists of a two-frequency laser interferometer, a 90° phase mixing electronics and a phase angle calculating electronics and

performs the steps of mixing a reference signal filtering high irregionary terms to produce output signals and obtaining a phase angle for displacement measurement, the phase angle measuring method comprising the steps of:

obtaining output signals output from the 90° phase mixing electronics, and ellipse parameters, such as amplitudes, offsets and a phase difference included in the output signals which are output from the 90° phase mixing electronics;

applying the ellipse parameters and the output signals to the following Equation to calculate the phase angle;

making out a lookup table with data which consists of the cutput signals and the phase angle corresponding with them; and

reading the phase angle corresponding with the output signals output from the lookup table when the displacement measurement is required in real application.

$$\theta = \tan^{-1}[\cos\theta / [\sin\theta + (b/a) / (I_x - I_{x0}) / (I_y - I_{y0})]]$$

3. A nonlinearity error correcting method for displacement measurement in a two-frequency laser interferometer, which consists of a two-frequency laser interferometer, a 90° phase mixing electronics, a nonlinearity error correcting electronics and a phase calculating electronics and performs the steps of mixing a reference signal produced due to an interference of two-frequency laser beams and a 90° phase shifted reference signal

with a measurement signal for displacement measurement produced due to an interference of two-frequency laser beams reflected on tixed and moving mirrors, filtering high frequency terms to produce output signals, and obtaining a phase angle for displacement measurement, the nonlinearity error correcting method comprising the steps of:

calculating ellipse parameters, such as amplitudes, offsets and a phase difference of output signals which are output from the 90° phase mixing electronics;

calculating adjusting voltages for correcting the output signals and offsets, amplitudes and a phase of the output signals; and

signals output from the nonlinearity error correcting electronics by the adjusting voltages become zero, amplitudes are same, and a phase difference beyond 90° between the output signals becomes zero.

4. A phase angle measuring method for displacement measurement in a two-frequency laser interferometer, which consists of a two-frequency laser interferometer, a 30° phase mixing electronics, a nonlinearity error correcting electronics and a phase calculating electronics and performs the steps of mixing a reference signal produced due to an interference of two-

with a measurement signal for displacement measurement produced due to an interference of two-frequency laser beams reflected on fixed and moving mirrors, filtering high frequency terms to produce output signals, and obtaining a phase angle for displacement measurement, the phase angle measuring method comprising the steps of:

calculating ellipse parameters, such as amplitudes, offsets and a phase difference of the output signals which are output from the nonlinearity error correcting electronics;

calculating adjusting voltages for correcting the output signals and offsets, amplitudes and a phase of the output signals;

signals output from the nonlinearity error correcting electronics due to the adjusting voltages become zero, amplitudes are same, and a difference beyond 90° between the output signals becomes zero; and

applying the output signals whose offsets, amplitudes and phase are corrected to the following Equation to calculate the phase angle,

 $\theta = \arctan(I_y/I_x)$

A phase angle measuring system for displacement measurement in a two-frequency laser interferometer, the phase angle measuring system comprising:

a two-frequency laser interferometer which outputs reference signal produced due to an interference of two frequency laser beams and a measurement signal for displacement measurement produced due to an interference of two frequency laser heams reirected on fixed and moving mirrors;

a 90° phase mixing electronics which mixes the reference signal and a 90° phase shifted reference signal with the measurement signal output from the interferometer, filters high frequency terms and outputs output signals for phase angle measurement;

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a nonlinearity error correcting electronics which receives again the output signals output from the nonlinearity error correcting electronics, obtains ellipse parameters such amplitudes, offsets and a difference from phase-quadrature of the cutput signals, calculates adjusting voltages for correcting the amplitudes and the offsets of the output signals, and conducts a and correction wherein offsets of the output signals become zero due to calculated adjusting voltages, amplitudes are same and a phase difference beyond 90° between the output signals becomes zero; and

a phase angle calculating electronics which obtains a phase angle by applying the output signals output from the nonlinearity error—correcting—electronics—to—the—following—Equation $\theta = \arctan(I_y/I_x')$

- 6. The phase angle measuring system of claim 5, wherein the interferometer includes:
- a laser which emits two orthogonally linear-polarized beams which have different frequencies;
- a beamsplitter which splits the laser into a measurement beam incident to a polarizing beamsplitter and a reference beam incident to a photodetector through a polarizer;

the photodetector which detects a reference signal as an interference signal of the two laser beams from the reference beam of the photodetector and provides the same to a first mixer and a 90° phase shifter;

the polarizing beamsplitter which splits the laser beam transmitted from the beamsplitter into two beams incident to a fixed mirror and a moving mirror, mixes two laser beams reflected from two mirrors; and

the photodetector which detects a measurement signal as an interference signal of the two laser beams from the measurement beam of the polarizing beamsplitter and provides the same to the first mixer and a second mixer.

a 90' phase shifter which 90' phase shifts the reference signal provided from a photodetector and provides the same to a second mixer;

a first mixer which mixes the reference signal output from the photodetector with the measurement signal output from the photodetector;

the second mixer which mixes 90° phase shifted reference signal through the 90° phase shifter with the measurement signal output from the photodetector; and

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low pass filters which filter high frequency terms from the output signals output from the mixers and provides the same to offset adjustment means.

- 8. The phase angle measuring system of claim 5, wherein the nonlinearity error correcting electronics includes:
- a microprocessor which obtains ellipse parameters such as amplitudes, offsets and a phase difference of output signals fed back from the nunlinearity error correcting electronics through an analogue-to-digital converter and calculates adjusting voltages for correcting the amplitudes, the offsets and the phase of the output signals;

offset adjustment means which conducts a correction wherein offsets of output signals fed back from the nonlinearity error emrrecting electronics due to the adjusting voltages output from the microprocessor through a digital-to-analogue converter become zero;

amplitude adjustment means which conduct a correction wherein amplitudes of the cutput signals fed back through the nonlinearity error correcting electronics by the adjusting voltages output from the microprocessor through the digital-to-analogue converter are same; and

phase adjustment means which conducts a correction wherein a phase value in excess of 90° between the output signals fed back through the nonlinearity error correcting electronics by the adjusting voltages output from the microprocessor through the digital-to-analogue converter becomes zero.

9. The phase angle measuring system of claim 5 or claim 8, wherein the offset adjustment means, the amplitude adjustment means and the phase adjustment means of the nonlinearity error extracting electronics can be arranged in a free order.